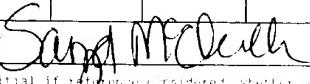
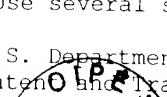


EXAMINER Jay Miller DATE CONSIDERED 6/22
EXAMINER: Initial if reference is made, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

FORM PTO-1449 MODIFIED		Case No.	Serial No.		
List of Patents and Publications Cited by Applicant (Use several sheets if necessary)		LDC-MASK			
U.S. Department of Commerce Patent and Trademark Office		09/809,606			
		Applicant: Hammesfahr et al			
		Filing Date March 15, 2001	Group		
U. S. PATENT DOCUMENTS					
Examiner Initial	Document No.	Date	Name	Class	Subclass
	5,879,159	3/99	Cipolla	433	29
	5,912,470	6/99	Eibofner et al	250	504
	5,975,895	11/99	Sullivan	433	29
	6,008,264	12/99	Ostler et al	522	4
	6,033,123	3/00	Narusawa et al	433	226
		6,079,861	6/00	Woodward et al	362
FOREIGN PATENT DOCUMENTS					
Examiner Initial	Document No.	Date	Country	Translation YES NO	
OTHER PAPER AND DRAWINGS REFERRED TO, TITLE, DATE, PERTINENT PARAGRAPH, ETC.					
EXAMINER 		DATE CONSIDERED <u>1/24/02</u>			
<small>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with RIFER. If reference is not in conformance and not considered, indicate by initialing this line with next examination date.</small>					

FORM PTO-1449 MODIFIED		Sheet 1 of 2	
List of Patents and Publications Cited by Applicant (Use several sheets if necessary)		Case No.	Serial No.
		LDC-MASK	09/809,606
U.S. Department of Commerce Patent and Trademark Office		Applicant: Hammesfahr et al	
		Filing Date March 15, 2001	Group

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Examiner Initial	Document No.	Date	Name	Class	Subclass
SMC	4,385,344	5/83	Gonser	362	32
↑	4,491,453	1/95	Foblitz et al	433	117
	4,514,174	4/95	Dougherty et al	433	126
	5,229,230	7/93	Famou	430	5
	5,290,169	3/94	Friedman et al	433	29
	5,468,577	11/95	France et al	514	562
	5,472,991	12/95	Schmitt et al	521	4
↓	5,521,592	5/96	Kennedy et al	250	492.1
	5,634,711	6/97	Kennedy et al	362	119
SMC	5,835,661	11/98	Tai et al	285	146

FOREIGN PATENT DOCUMENTS

OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

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EXAMINER: Initial if reference considered, whether or not in accordance with MIEC 659;划线表明是否参考了MIEC 659,但不考虑其是否符合规定。